

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of : Customer Number: 89518  
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Mou-Shiung Lin et al. : Confirmation Number: 6138  
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Application No.: 09/523,990 : Group Art Unit: 2887  
:   
Filed: March 13, 2000 : Examiner: Daniel I. Walsh  
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For: METHOD OF MANUFACTURE AND IDENTIFICATION OF SEMICONDUCTOR  
CHIP MARKED FOR IDENTIFICATION WITH INTERNAL MARKING INDICIA  
AND PROTECTION THEREOF BY NON-BLACK LAYER AND DEVICE  
PRODUCED THEREBY

**CHANGE TO LARGE ENTITY STATUS**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**CERTIFICATE OF ELECTRONIC TRANSMISSION**

I hereby certify that this correspondence is being electronically-transmitted to  
the United States Patent and Trademark Office on April 9, 2010.  
/Tobi A. Herbert/

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Tobi A. Herbert

Sir:

This communication hereby notifies the United States Patent and Trademark Office of a  
change in status of the above-identified application from small entity to large entity. Any fees  
due in the above-identified application will be paid as large entity to reflect this change.

Respectfully submitted,  
McDERMOTT WILL & EMERY LLP

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**Date: April 9, 2010**

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as our correspondence address.**